

	Hits	Search Text	DBs	Time Stamp
1	9607	(semiconductor or wafer or substrate) and (chamber or enclosure or enclosed or vessel) and temperature and vapor and (sensor or sense or thermometer or humidistat) and (DI or IPA or alcohol or isopropyl)	US- PGPUB; USPAT; USOCR; EPO; JPO; DERWEN T	2004/11/24 11:06
2	91	(semiconductor or wafer or substrate) and (chamber or enclosure or enclosed or vessel) and temperature and vapor and (sensor or sense or thermometer or humidistat) and (DI or IPA or alcohol or isopropyl) and "34"/*.ccls.	US- PGPUB; USPAT; USOCR; EPO; JPO; DERWEN T	2004/11/24 11:06
3	300	(semiconductor or wafer or substrate) and (chamber or enclosure or enclosed or vessel) and temperature and vapor and (sensor or sense or thermometer or humidistat) and (DI or IPA or alcohol or isopropyl) and "134"/*.ccls.	US- PGPUB; USPAT; USOCR; EPO; JPO; DERWEN T	2004/11/24 11:07
4	260	2 or 3 and @pd<"20021016"	US- PGPUB; USPAT; USOCR; EPO; JPO; DERWEN T	2004/11/24 11:07